



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Ichio YUDASAKA et al.

Application No.: 09/936,040

Filed: December 11, 2001

For: A THIN FILM TRANSISTOR AND A METHOD FOR MANUFACTURING
THEREOF

Group Art Unit: 2826

Examiner: A. Sefer

Docket No.: 110554

q/Election
7-302
A.Weller

RESPONSE TO RESTRICTION REQUIREMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

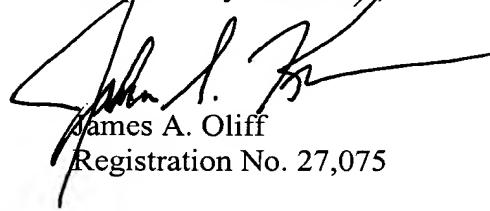
In reply to the Restriction Requirement mailed May 30, 2002, Applicants
provisionally elect Group I, claims 1-7, 13-16 and 17 drawn to Device, with traverse.

It is also respectfully submitted that the subject matter of all claims 1-18 is
sufficiently related that a thorough search for the subject matter of any one Group of claims
would encompass a search for the subject matter of the remaining claims. Thus, it is
respectfully submitted that the search and examination of the entire application could be
made without serious burden. See MPEP §803 in which it is stated that "if the search and
examination of the entire application can be made without serious burden, the Examiner must
examine it on the merits even though it includes claims to distinct or independent inventions"
(emphasis added). It is respectfully submitted that this policy should apply in the present
application in order to avoid unnecessary delay and expense to Applicants and duplicative
examination by the Patent Office.

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Thus, withdrawal of the Restriction Requirement is respectfully requested.

Respectfully submitted,



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JAO:JSK/kap

Date: June 26, 2002

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